Notice of Allowability	Application No.	Applicant(s)	
	10/613,200	CHOU ET AL.	\
	Examiner	Art Unit	~
	Mai-Huong Tran	2818	*
The MAILING DATE of this communication appears on the cover sheet with the correspondence address All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308. 1. This communication is responsive to 9/15/04.			
2. X The allowed claim(s) is/are <u>1 and 3-14</u> .			
3. The drawings filed on 03 July 2003 are accepted by the Examiner.			
 4. Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a)			
Attachment(s) 1. ☐ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3. ☑ Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date 7/3/03 4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material	8. Examiner's Statement 9. Other David Nelms	(PTO-413), te ment/Comment ent of Reasons for Allo	,
	Supervisory Patent Examiner Technology Center 2800		

DETAILED ACTION

Examiner's Amendment.

An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Cancel claims 2 and 15-36.

Reason for allowance

The following is an examiner's statement of reason for allowance: None of the references of record teaches or suggests the claimed Organic Device Including Semiconducting Layer Aligned According to Microgrooves of Photresist Layer having a plurality of microgrooves that are located in different regions of the substrate, and wherein the microgrooves in the same region have the same alignment direction and the microgrooves in different regions have the same or different alignment directions.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance".

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Conclusion

Any inquiry concerning this communication on earlier communications from the examiner should be directed to Mai-Huong Tran, (571) 272-1796. The examiner can normally be reached on Monday-Thursday from 8:00 AM to 6:30 PM. The examiner's supervisor, David Nelms can be reached on (571) 272-1787.

The fax phone number for the organization where this application or proceeding is assigned is (703) 872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR, Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Mai-Huong Tran

David Nelms
Supervisory Patent Examiner
Technology Center 2800